

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	180889	(wafer\$4 OR substrate\$4) NEAR20 (clean\$4 OR etch\$4)	US-PGPUB; USPAT	OR	OFF	2006/04/24 18:05
L2	4147	L1 AND ((liquid\$4 OR wet\$4 OR acid\$4) NEAR20 etch\$4) AND ((infra\$1red\$4 OR radiat\$4) NEAR20 heat\$4)	US-PGPUB; USPAT	OR	OFF	2006/04/24 18:06
L3	156	L2 AND ((liquid\$4 OR wet\$4 OR acid\$4) NEAR20 etch\$4 NEAR20 (infra\$1red\$4 OR radiat\$4))	US-PGPUB; USPAT	OR	OFF	2006/04/24 18:02
L4	6672	((438/745,746,753,754,756,757) or (216/83,87,94,96,99,100-108)). CCLS.	US-PGPUB; USPAT	OR	OFF	2006/04/24 18:03
L5	10	L3 AND L4	US-PGPUB; USPAT	OR	OFF	2006/04/24 18:03
L6	116270	(wafer\$4 OR substrate\$4) NEAR20 (clean\$4 OR etch\$4)	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/04/24 18:05
L7	49	L6 AND ((liquid\$4 OR wet\$4 OR acid\$4) NEAR20 etch\$4) AND ((infra\$1red\$4 OR radiat\$4) NEAR20 heat\$4)	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/04/24 18:06